

LG710574049

Report verification at igi.org

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 10, 2025

IGI Report Number LG710574049

Description LABORATORY GROWN DIAMOND

Shape and Cutting Style **EMERALD CUT**

Measurements 6.85 X 5.05 X 3.10 MM

GRADING RESULTS

Carat Weight 1.03 CARAT

Color Grade

Clarity Grade VS 1

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

EXCELLENT Symmetry

Fluorescence NONE

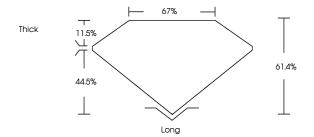
(塔) LG710574049 Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth

process. Type IIa

PROPORTIONS

D





Sample Image Used

COLOR

| D E F | G H I J | Faint | Very Light | Light |
|------------------------|--------------------------------|---------------------------|----------------------|----------|
| CLARITY | | | | |
| IF | WS ^{1 - 2} | VS 1-2 | SI 1-2 | I 1-3 |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



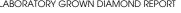
| | | | Y_ | | |
|------------------------|--------------------------------|---------------------------|----------------------|----------|--|
| CLARITY | | | | | |
| IF | VVS ^{1 - 2} | VS ¹⁻² | SI ¹⁻² | 1 1 - 3 | |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included | |



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BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCRED DOCUMENT SECURITY INDUSTRY GUIDELINES.



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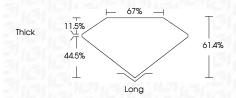
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